

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
SEP 27 2002  
TECHNOLOGY CENTER 2800

In re Patent Application of )  
Shunpei YAMAZAKI et al. )  
Serial No. 09/352,362 )  
Filed: July 13, 1999 )  
For: CRYSTALLINE SEMICONDUCTOR )  
THIN FILM, METHOD OF FABRICATING )  
THE SAME, SEMICONDUCTOR DEVICE, )  
AND METHOD OF FABRICATING THE )  
SAME )

Art Unit: 2815  
Examiner: J. Diaz

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with  
The United States Postal Service with sufficient postage as First  
Class Mail in an envelope addressed to: Commissioner for Patents,  
Washington, D.C. 20231, on 9/25/02

J. M. Milla  
10/15/02

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, DC 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be considered by the Examiner and made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

These references were cited in related application serial numbers 09/352,194 and 09/894,125.

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

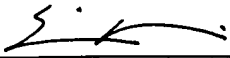
The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 50-2280.

Respectfully submitted,

09/26/2002 MMEKONEN 00000054 09352362

02 FC:126

180.00 OP

  
Eric J. Robinson  
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.  
PMB 955  
21010 Southbank Street  
Potomac Falls, Virginia 20165  
(571) 434-6789